

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Attorney Docket No.: 1501-1241	Application No.: NEW NONPROVISIONAL 10/812925
	Applicant: Tomas LANNESTEDT	
	Filing Date: March 31, 2004	Group Art Unit: 2884

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)
DEB	5,045,937	9/3/1991	MYRICK			
DEB	5,005,083	4/2/1991	GRAGE et al.			

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
DEB	WO 02/091741	11/14/2002	INTERNATIONAL				
	0 302 602	2/8/1989	EUROPE				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	HAL BEN, J.: Ny kamerateknik med aktiv digital termovideo-basis for reeltids termografi. Elteknik, /Elektronik, Automation og Energi/, 19. Argang Nr.3 Marts 2002, pages 2-3

EXAMINER:

David A. Baker DAVID S. BAKER

DATE CONSIDERED

14 March 2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* Abstract provided for the Examiner's convenience

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